IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

H. WATANABE et al

Serial No.: 09/320,271

Filed: May 27, 1999



Group Art Unit: 2815

Examiner: A. Wilson

For: SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREOF

RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Date: August 6, 1999

Sir:

This paper is submitted in response to the Official Action dated July 26, 1999.

In the Action, restriction is required between Group (I), Claims 1-13; and Group (II), Claims 14-20.

Applicants hereby elect the subject matter of Group (I), Claims 1-13 for prosecution in this application. This election is made without traverse, it being understood that the applicants' rights to the filing of a divisional application directed to the non-elected subject matter under 35 USC §120 and 35 USC §121 are retained.

ÄUS -9 1999 TC 2800 MAII BOOK In the event any additional fees are required in connection with this response, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN, HATTORI, McLELAND & NAUGHTON

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